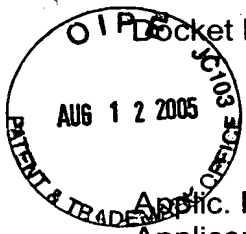


2878<sup>zw</sup>



Docket No.: GR 99 P 5374

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 09/729,069 Confirmation No: 6450  
Applicant : Nicolas Nagel, et al.  
Filed : December 4, 2000  
Art Unit : 2818  
Examiner : David Vu  
Title : Microelectronic Structure and Method of Fabricating it  
Docket No. : GR 99 P 5374  
Customer No. : 24131

STATUS LETTER

Commissioner for Patents,  
P.O. Box 1450, Alexandria, VA 22313-1450

Sir:

It is respectfully requested that this Status Letter be returned to:

LERNER AND GREENBERG, P.A.  
Post Office Box 2480  
Hollywood, FL 33022-2480  
Tel: (954) 925-1100  
Fax: (954) 925-1101

with an indication as to when an action may be expected.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Alexia J. Vrahimis".

Alexia J. Vrahimis

Date: August 9, 2005

/av